

JUL 28 2006

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**SCULLY, SCOTT, MURPHY  
& PRESSER**

# Fax

<b>To:</b>	Examiner: Jack S. J. Chen Art Unit: 2813	<b>From:</b>	Yongzhi Yang, Esq.
<b>Fax:</b>	571-273-8300	<b>Pages:</b>	47 pages including fax cover sheet
<b>Phone:</b>		<b>Date:</b>	7/28/2006
<b>Re:</b>	U.S. Patent Appln. 10/674,646 Filed: September 30, 2003 Docket: YOR920030320US1 (16868) Confirmation No. 4797	<b>CC:</b>	

## RESPONSE TO OFFICE ACTION

Please see the following documents:

1. Amendment Transmittal (in duplicate)
2. Authorization to charge IBM deposit account
3. Response Under 37 C.F.R. § 1.111 and Corrected § 131 Declaration (7 pages)
4. Exhibit A (9 pages)
5. Exhibit B (27 pages)
6. Certificate of transmission by facsimile dated July 28, 2006

If you have any questions concerning this facsimile please contact Vivian Henriquez at 516-742-4343.  
Thank you.

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JUL 28 2006

## CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)

Applicant(s): William G. America et al.

Docket No.

YOR920030320US1 (16868)

Application No.

10/674,646

Filing Date

September 30, 2003

Examiner

Jack S. J. Chen

Group Art Unit

2813

Invention: PLASMA SURFACE MODIFICATION AND PASSIVATION OF ORGANO-SILICATE GLASS FILMS FOR IMPROVED HARDMASK ADHESION AND OPTIMAL RIE PROCESSING

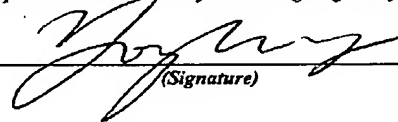
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P18/REV02

JUL 28 2006

Docket No.

YOR920030320US1 (16868)

**TRANSMITTAL LETTER**  
**(General - Patent Pending)**In Re Application Of: **William G. America et al.**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/674,646	September 30, 2003	Jack S. J. Chen	23389	2813	4797


**Title: PLASMA SURFACE MODIFICATION AND PASSIVATION OF ORGANO-SILICATE GLASS FILMS FOR IMPROVED HARDMASK ADHESION AND OPTIMAL RIE PROCESSING****COMMISSIONER FOR PATENTS:**

Transmitted herewith is:

**RESPONSE UNDER 37 C.F.R. § 1.111 AND CORRECTED §131 DECLARATION**

in the above identified application.

- ☒ No additional fee is required.
- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **50-0510/IBM** as described below.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.
- ☐ Payment by credit card. Form PTO-2038 is attached.

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SignatureDated: **July 28, 2006**

Yongzhi Yang  
Registration No. 56,310  
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on \_\_\_\_\_

(Date)

Signature of Person Mailing Correspondence

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CC:

P16A/REV03

JUL 28 2006

TRANSMITTAL LETTER  
(General - Patent Pending)Docket No.  
YOR920030320US1 (16868)

In Re Application Of: William G. America et al.

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
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